

Notice of References Cited

Application/Control No.

10/522,481

Applicant(s)/Patent Under
Reexamination
CHA ET AL.

Examiner

Quyen P. Leung

Art Unit

2874

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0024623	02-2002	Kim et al.	349/58
	B	US-			
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	D	US-			
	E	US-			
	F	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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